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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q68709

Minoru OGASAWARA, et al.

Appln. No.: 10/069,573

Group Art Unit: 1743

Confirmation No.: 1530

Examiner: Not Yet Assigned

Filed: February 27, 2002

For: HYDROGEN-FLAME PHOTOMETRIC ANALYZER FOR THIN-LAYER  
CHROMATOGRAPH AND HYDROGEN-FLAME PHOTOMETRIC ANALYZING METHOD

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REQUEST FOR CORRECTED OFFICIAL FILING RECEIPT

Commissioner for Patents  
Office of Initial Patent Examination  
Customer Service Center  
Washington, D.C. 20231

Sir:

We enclose a copy of the Official Filing Receipt for the above-identified application and request the following correction:

Title: [Hydrogen flame luminosity analyzer for thin-layer chromatograph, and hydrogen flame luminosity analyzing method] Hydrogen-flame Photometric Analyzer for thin-layer Chromatograph and Hydrogen-Flame Photometric Analyzing method

Domestic Priority data as claimed by applicant: PCT/JP01-05699 [06/30/2000] 07/02/200

Verification for the requested correction is indicated on the original Declaration Power of

Attorney filed February 27, 2002.

Respectfully submitted,

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Date: August 13, 2002



## UNITED STATES PATENT AND TRADEMARK OFFICE

COMMISSIONER FOR PATENTS  
UNITED STATES PATENT AND TRADEMARK OFFICE  
WASHINGTON, D.C. 20231  
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APPLICATION NUMBER	FILING DATE	GRP ART UNIT	FIL FEE REC'D	ATTY. DOCKET NO.	DRAWINGS	TOT CLAIMS	IND CLAIMS
✓ 10/069,573	✓ 02/27/2002	1743	✓ 1170	✓ Q68709	✓ 3	✓ 8	2

CONFIRMATION NO. 1530

23373  
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WASHINGTON, DC 20037

## FILING RECEIPT



\*OC000000008032044\*

Date Mailed: 05/09/2002

Receipt is acknowledged of this nonprovisional Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Filing Receipt Corrections, facsimile number 703-746-9195. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

## Applicant(s)

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## Domestic Priority data as claimed by applicant

THIS APPLICATION IS A 371 OF PCT/JP01/05699 06/30/2000

07/20/01

## Foreign Applications

JAPAN 2000-198938 06/30/2000

Projected Publication Date: Not Applicable, filed prior to November 29, 2000

Non-Publication Request: No

Early Publication Request: No

## Title

[Hydrogen flame luminosity analyzer for thin-layer chromatograph, and hydrogen flame luminosity analyzing method]

## Preliminary Class

Hydrogen-Flame Photometric Analyzer for thin-layer chromatograph and Hydrogen-Flame photometric Analyzing method

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